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Total Number of Pages: 02

M.Tech
VLPE206

2nd Semester Regular / Back Examination 2015-16
EMERGING TOPICS IN IC DESIGN
Q.CODE:W932
Time: 3 Hours
Max Marks: 70

Answer Question No.1 which is compulsory and any five from the rest.
The figures in the right hand margin indicate marks.
Assume values wherever missing

- Q1** Answer the following questions: **(2 x 10)**
- a) What are the drawbacks of JFET? Enlist some alternative configurations
 - b) Find the maximum width of the depletion region for an ideal MOS capacitor on p-type Si in strong inversion given that the doping concentration is 10^{16} cm^{-3} and the relative dielectric constant is 11.8.
 - c) Enlist some properties of ideal MIS systems.
 - d) Calculate the cutoff frequency of a MOSFET given the following information: $L = 1 \mu\text{m}$; n-channel device with a p-type substrate; $\mu'_n = 1200 \text{ cm}^2/(\text{V s})$; $Z = 10 L$; $V_T = 1.1 \text{ V}$; and $V_G = 5\text{V}$.
 - e) Enlist the important features that arise in short-channel MOSFETs.
 - f) Mention some key advantages of molecular materials.
 - g) Differentiate between an Inverting type nMOS super buffer and a Non-inverting type nMOS super buffer
 - h) Design an AOI Logic Circuit for the given SOP expression:
$$F = \bar{A}\bar{B}\bar{C}D + BC\bar{D} + A\bar{B}$$
 - i) Implement a 2:1 MUX using TG logic.
 - j) What is hierarchy? How does it help in modular design?
- Q2**
- a) Discuss the behavior of a MESFET under different gate bias conditions with suitable illustrations. **(5)**
 - b) What is a MODFET? Give its basic device structure. What do you understand by 2 DEG? **(5)**
- Q3**
- a) Draw and explain the Energy band diagram for an ideal MIS structure in equilibrium. **(5)**
 - b) Calculate the threshold voltage for a MIS structure given the following information. **(5)**
Let the semiconductor be p-type Si and the metal be Al. The doping concentration is $N_a = 10^{17} \text{ cm}^{-3}$, the oxide thickness is $d = 10 \text{ nm}$, the work

function difference $\phi_{ms} = -1.05$ V, the insulator surface charge density is $Q_i = 5 \times 10^{10} q$ C/cm², and $\kappa_i = 3.9$. Determine the depletion region width, W , the flat band voltage, V_{FB} and the threshold voltage, V_T .

- Q4** Consider an n-channel MOSFET with the following information: **(10)**
 $N_a = 5 \times 10^{16} \text{ cm}^{-3}$; $\mu'_n = 500 \text{ cm}^2/(\text{V s})$; $\phi_{ms} = -0.96$ V; $Q_i = 5 \times 10^{10} q/\text{cm}^2$; $Z = 50 \mu\text{m}$; $d = 30 \text{ nm}$; $L = 5 \mu\text{m}$; $n_i = 10^{10} \text{ cm}^{-3}$; $\kappa_0 = 3.9$; $E_g = 1.12 \text{ eV}$; $\kappa_s = 11.9$.
(i) Determine the drain current at a gate voltage $V_G = 2$ V and a drain voltage $V_D = 1$ V.
(ii) Consider the case where the gate voltage is 3 V and the drain voltage in 4 V.
- Q5 a)** An n-channel MOSFET is to be scaled using constant voltage scaling. If the scaling factor λ is 0.7, determine the new device parameters given that the original device has $L = 1.0 \mu\text{m}$, $Z = 100 \text{ mm}$, d (the oxide thickness) = 25 nm, $N_a = 5 \times 10^{15} \text{ cm}^{-3}$, and the applied voltage is 3 V. **(5)**
- b)** Determine the thickness of the Si active layer in a partially depleted SOI device if the layer is only 50% depleted in equilibrium. Assume that the Schottky barrier height is 0.72 eV, the effective density of states within the conduction band is $N_c = 3.22 \times 10^{19} \text{ cm}^{-3}$, and the doping concentration is 10^{16} cm^{-3} . Assume that all of the donors are ionized. **(5)**
- Q6 a)** What do you mean by steering logic? Discuss design of any combinational circuit using steering logic. **(5)**
- b)** Compare between Semicustom and Full custom design strategies. **(5)**
- Q7 a)** Determine how the Poisson equation scales under: **(5)**
(i) Constant voltage scaling.
(ii) Quasi-constant voltage scaling.
- b)** Compare between CMOS and BICMOS logic. **(5)**
- Q8** Write short notes on any two: **(5 x 2)**
a) CMOS static plots
b) Small Signal operation of MOSFETS
c) Carbon Nano tubes
d) Moletronics